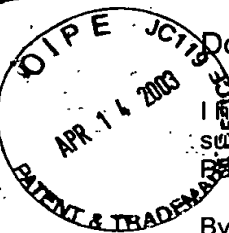


1763



Docket No.: P2000,0145

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the date indicated below:

By: Markus Nollf

Date: April 9, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7
4116103
m2

Inventor : Anne Kurtenbach et al.
Applic. No. : 09/923,701
Filed : August 6, 2001
Title : Apparatus and Method for Removing an Organic Material from a Semiconductor Device
Examiner : Parviz Hassanzadeh - Art Unit: 1763

RESPONSE

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'APR 16 2003'

TC 1700

Hon. Commissioner of Patents and Trademarks,
Washington, D. C. 20231

Sir:

Responsive to the Office Action dated March 17, 2003, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group II, claims 10-20, for prosecution at this time.

Applicants reserve the right to file a divisional application including the device claims of group I at a later date.

In view of the foregoing, the early issuance of an Action on the merits of claims is solicited.

Respectfully submitted,

Markus Nollf

For Applicants

Markus Nollf
Reg. No. 37,006

Date: April 9, 2003

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